

# EUROPEAN PATENT OFFICE

## Patent Abstracts of Japan

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APPLICANT : HITACHI LTD;

INVENTOR : SATO HISASHI;

INT.CL. : H01J 37/14

TITLE : MAGETIC FIELD TYPE ELECTRONIC LENS

ABSTRACT : PURPOSE: To designa magnetic path so that pole void becomes minus tolerance and to absorb an alteration of the pole void portion by a non-magnetic material spacer.

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